



PATENT

Attorney Docket No.: 000306 X13

RW Ref. No.: APM/079-95-CP1-CN1-CPA-DV1-RCE1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
Kenneth COLLINS, ET AL.)	Group Art Unit: 1763
)	
Entitled: PLASMA REACTOR HAVING AN)	Examiner: Luz Alejandro
RF POWER APPLICATOR AND A DUAL-)	
PURPOSE WINDOW)	
)	
Serial No.: 10/021,195)	
)	
Filing Date: October 30, 2001)	

INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR 1.97(b)

Mail Stop RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Attached hereto is Form PTO-1449 listing documents believed relevant to the subject application. It is respectfully requested that these documents be made of record and an initialed copy of each form be returned to the undersigned.

No representation is made that more pertinent material is not available or should not be considered by the Examiner. It is expected that the Patent and Trademark Office will independently conduct a complete search of appropriate art. Furthermore, no admission is being made that these documents are prior art, and applicant reserves the right to challenge any such consideration.

It is believed that this disclosure complies with the requirements of 37 CFR 1.56, 1.97, and 1.98, and the Manual of Patent Examining Procedures, section 609 and 707.05. If for some reason the Examiner considers otherwise, it is respectfully

requested that the undersigned be called so that any deficiencies can be remedied.

A copy of each foreign patent document and/or non-patent literature is enclosed unless indicated otherwise. Some of the documents may have markings on them. No significance is meant to be attached to the markings. These documents are not necessarily analogous art.

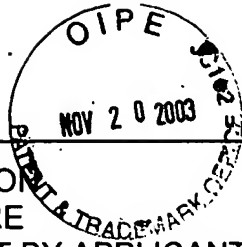
Respectfully submitted,

A handwritten signature in cursive script, reading "Robert M. Wallace".

Dated: November 19, 2003

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INFORMATION
DISCLOSURE
STATEMENT BY APPLICANT

Sheet 1 of 1

Application Number: 10/021,195
Filing Date: October 30, 2001
First Named Inventor: Kenneth COLLINS, et al.
Group Art Unit: 1763
Examiner Name: Luz Alejandro-Mulero
Attorney Docket Number: 000306 X13

U. S. PATENT DOCUMENTS

Examiner Initials	Document No	Publication Date	Name of Patentee or Applicant of Cited Document	Class	Subclass	Filing Date
	US-5,286,344	02-15-1994	BLALOCK ET AL.	156	657	06-15-92
	US-5,356,515	10-18-1994	TAHARA ET AL.	156	643	12-10-92
	US-5,366,590	11-22-1994	KADOMURA	156	662	03-17-94
	US-5,770,098	06-23-1998	ARAKI ET AL.	216	67	03-16-94

FOREIGN PATENT DOCUMENTS

Examiner Initials	Foreign Patent Document	Publication Date	Country	Name of Patentee or Applicant of Cited Document	Translation? (Yes/No/n/a)

NON PATENT LITERATURE DOCUMENTS

Examiner Initials	
	KELLER, JOHN, "Inductive plasmas for plasma processing", Plasma Sources Sci. Technol., Vol. 5, 1996, pp 166-172, UK.

Examiner's Signature:

Date Considered:

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.